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Stable negative differential resistance in porphyrin based σ - π - σ monolayers grafted on silicon†

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Two Si-based hybrid self-assembled monolayers were synthesized by electro-grafting two di-*O*-alkylated porphyrins as the σ - π - σ systems. The monolayers showed a stable and reversible negative differential resistance (NDR) property at room temperature. The monolayer, fabricated using the porphyrin with fluorophenyl groups was more compact and showed a tenfold peak-to-valley ratio (PVR) relative to the other similar system devoid of the fluorine atoms in the porphyrin moiety. This suggested better pre-organization of the former, possibly by hydrogen bonding through the electro-negative fluorine atoms.

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Introduction

Extensive research is being carried out on electron-transfer (ET) processes through molecular scaffolds due to their potential technological applications in molecular electronic devices.¹ Studies have demonstrated that besides the junction geometry, the structures of the incorporated molecules also dictate the electron-transfer rates, current-voltage (*J*-*V*) curves and the behaviour of the resulting devices.^{2a-g} Self-assembled systems of organic molecules on metal/semiconductor substrates, prepared by Langmuir-Blodgett (LB) films, or chemically-grafted monolayers of organic molecules junction is a powerful 'bottom-up' approach for the fabrication of devices for molecular-scale electronics.³ Integration of molecular components into electronic circuits by grafting on Si is expected to miniaturize the electronic circuits to nanoscale.⁴ This approach offers the advantage of tailoring the surface potential for improved hybrid molecular devices, changing the p-n junction threshold voltage by adjustment of the electronic nature and/or use of multiple oxidation states of the organic π group molecules, instead of classical doping of silicon.⁵ The negative differential resistance (NDR) behavior (*i.e.*, an initial rise in current and its subsequent sharp drop even with progressively augmented voltage, as opposed to Ohm's law) has drawn significant attention because of its potential application in realization of logic devices and memory circuits,^{2b,6} and is found in a variety of molecular devices.^{4b,7} NDR effects have been reported using various organic molecules and different types of junctions. Some representative examples include (i) boron

doped Si (111) surfaces,^{8a,b} diamond films,^{8c} and thiols on Au surfaces (all at room temperature),^{8d} (ii) 2'-amino-4,4'-di(ethylphenyl)-5'-nitro-1-benzenethiol, sandwiched between two metal electrodes (observed at 60 K),^{2b} (iii) Pd/ferrocene self-assembled layer/Au structure,^{8e} (iv) cyclopentene molecules, deposited on p-type hydrogen free Si(001) (observed at 80 K),^{2b} (v) styrene and 2,2,6,6-tetramethyl-1-piperidinyloxy, deposited on degenerately doped Si (100) reconstructed surfaces,^{8f} and (vi) disulfide molecules deposited on Si.^{8g} In an interesting study, organic molecules deposited on doped Si (100) surfaces by ultrahigh vacuum scanning tunnelling microscope (STM) showed room temperature NDR behaviour that was decided by the nature of the molecules and the dopants.^{8h} In all these cases, the resonant and off-resonant electronic tunneling mechanism provide satisfactory explanations for the NDR behavior.⁹ A large peak-to-valley ratio (PVR) in the NDR effect, required for fast switching and functioning of the device at room temperature with high reproducibility are the prerequisites for applications in hybrid nanoelectronics. Most of the reported molecular hybrids, exhibiting the NDR behaviour did not fulfil many of these criteria, and the measurements were carried out under ultra-high vacuum in certain cases. Some of the devices were made using expensive techniques such as STM, and require appropriate biasing and doping. Due to the variation of the electronic structures of the STM tips during experimentation, NDR may occur at different bias magnitudes and polarities. Also, routine impurity doping is problematic due to uncertainty of its distribution.¹⁰

Thus, despite impressive progress in molecular electronics, search for alternate single molecules or a finite ensemble of self-assembled molecules showing NDR property at a lower bias is currently an active research area in molecular electronics. Amongst the electron-rich organic molecules, porphyrins¹¹ are used extensively in fabricating molecular devices because they (i) form stable π -cation radicals, and exhibit two accessible

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cationic states in monomeric forms;^{12a-e} (ii) have long charge retention times, hence less power consumption, (iii) are highly stable,^{12f} and (iv) can form self-assembled structures.^{12g} Despite all these attributes and theoretical proposition,^{8h,13} scarce attention has been paid to construct porphyrin-based NDR devices experimentally. Previously, the J - V curves of some porphyrin-metal ions combinations showed NDR-like effect.^{14a-c} We have also found electrical bistability and current rectification properties of some porphyrin monolayers on Si surfaces.^{14d,e} More recently, metal-free and Zn-bis-porphyrin molecules have been used as efficient chemosensors for Cl₂ and NH₃ gases in air.¹⁵ Presently, we fabricated redox-active porphyrin monolayers on Si and investigated the possibility of using the oxidation states of the porphyrin molecules as molecular-scale information storage systems. The prime aim was to develop devices that are environmentally stable, and show high repeatability and easy processability. Studies on the J - V characteristics of the hybrid systems revealed stable, reversible, reproducible, and room temperature NDR behaviour by both the systems. We also demonstrate that the NDR property can be tuned by subtle changes in the porphyrin structure by incorporating an electro-negative substituent (F) at the *meso*-phenyl groups.

Results and discussions

Given the importance of the molecular bridges in nano-devices, design of the organic molecule is crucial in attaining our objectives. The molecular design was conceived keeping in mind that the energy gap (ΔE) between the energy states (LUMO/HOMO) of the molecular bridges and the Fermi levels of the donor and acceptor units control the electron-transfer rate and current flow.¹⁶ For large ΔE , the ET process is dominated by a “through-bond” non-resonant tunnelling mechanism, where the organic molecules generally act as poor electron conductors. However, alteration of their electronic structures can induce the ET process *via* a resonant tunnelling or a hopping mechanism. The change from a non-resonant to resonant tunnelling would result in an abrupt increase in the current, and the measured J - V curves would show NDR characteristics.¹⁷ Resonant tunnelling requires a double potential barrier along the electron transfer coordinates. Earlier, we have proposed a possible physical origin for such a double potential barrier, and hypothesized that the σ - π - σ monolayers, grafted on Si might show NDR effect.^{14d} The σ - π - σ molecular architecture is analogous to the tunnel diode, with a ‘quantum well’ surrounded by thin layer barriers.¹⁸ Here, the π -moiety (a conjugated molecule) acts as a quantum well and the σ -moieties (alkyl chains) as the tunnel barriers. The NDR effect in such a monolayer is expected, if electrons tunnel through some resonant states of the π -moiety. Our previous studies with *N*-(2-(4-diazoniophenyl)ethyl)-*N'*-hexylnaphthalene-1,8,4,5 tetracarboxy diimide tetrafluoroborate as a σ - π - σ molecule showed poor NDR effect (PVR ~ 10) with hysteresis, but established the hypothesis.¹⁹ Hence, we synthesized two new di-*O*-alkylatedporphyrins **5a** and **5b** with tetraphenylporphyrin (TPP) and a fluoro-TPP derivatives as the respective quantum wells (π moiety), and a C₆-alkyl chain

and a C₁₁-alkenyl chain as the barriers. The choice of the alkenyl chain as one of the barriers was a part of the molecular design, because this helped in electro-grafting monolayers of the molecules on Si (111) surfaces. Subsequently, the possibility of using the oxidation states of the porphyrin molecules as molecular-scale devices was investigated using the fabricated porphyrin-Si hybrids.

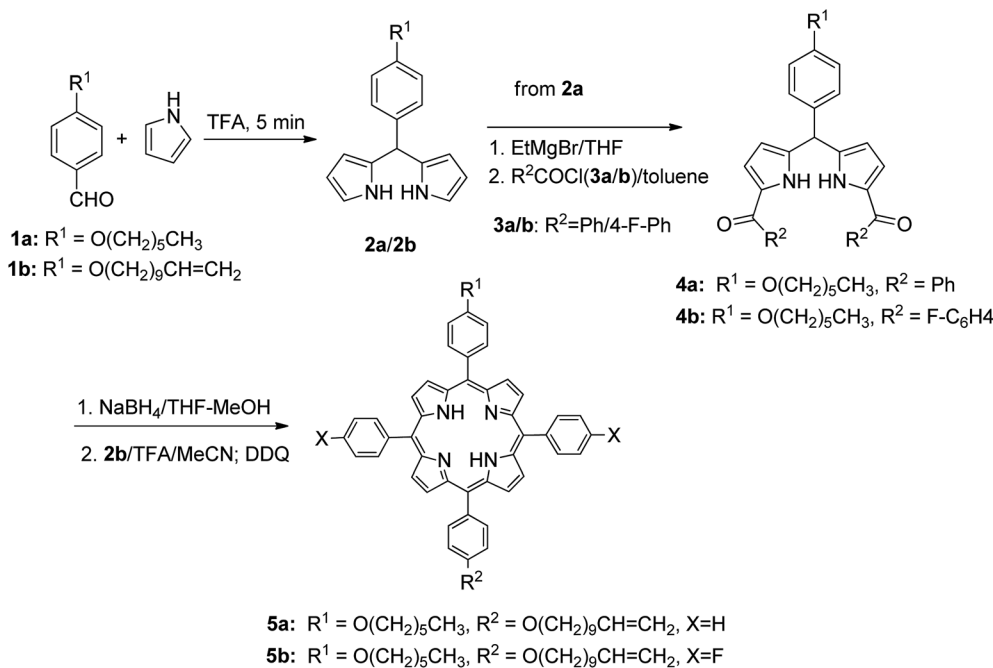
Synthesis of porphyrins 5a and 5b

The classical one-pot method of Adler and Longo involving an acid-catalyzed reaction between pyrrole and an aryl aldehyde under refluxing conditions is suitable for the synthesis of symmetric (A₄-Por) or partially symmetric (A₃B-Por) porphyrins, where A and B are the *meso*-aryl substituents.^{20a} Extension of the method to synthesize porphyrins, bearing two or more types of *meso*-substituents provides a statistical mixture of six porphyrins from which isolation of pure compounds becomes extremely difficult. Hence, we adopted Lindsey's method involving a “2 + 2” route using a dipyrromethane-1,9-dicarbonyl and a dipyrromethane (bearing ABC- and D-substituents, respectively) for the synthesis of the target porphyrins **5a** and **5b**.^{20b} This involved a base-catalyzed alkylation of 4-hydroxybenzaldehyde with 1-bromohexane and 11-bromoundec-1-ene to furnish the aldehydes **1a** and **1b** respectively. The aldehydes were individually subjected to a trifluoroacetic acid (TFA)-catalyzed condensation with pyrrole to yield the dipyrromethanes **2a** and **2b** respectively. Compound **2a** was subsequently acylated with benzoyl chloride (**3a**) or 4-fluorobenzoyl chloride (**3b**) using EtMgBr as the base to afford the ketones **4a** and **4b** respectively. This reaction is tricky and produces both mono- and di-acylated products if the stoichiometry and reaction temperature are not maintained carefully. The ketones **4a** and **4b** were subsequently reduced with NaBH₄ and the resultant unstable diols were converted to the porphyrins **5a** and **5b** *via* a TFA-catalyzed condensation with **2b** followed by a 2,3-dichloro-5,6-dicyano-1,4-benzoquinone (DDQ) oxidation, the three-steps process being carried out in one-pot (Scheme 1).

Preparation of the grafted organic assembly

Physisorption of organic molecules as Pockels–Langmuir (PL) films or by vapor-phase deposition on electrodes is often used to fabricate hybrid organic electronic devices. However, ordering of PL films is usually achievable with amphiphilic molecules only, restricting the molecular design. On the other hand, the vapor-phase deposition method often results in poor deposition yields, disordered packing and random orientations. Further, the physisorbed molecules often move to seek a lower energetic state on the surface, or in response to an applied electric field. Instead, covalent linking of organic molecules to metal/semiconductor surfaces provides a better alternative.²¹ Extensive work has been carried out by attaching organic thiol molecules to Au electrodes. But, the Au surfaces are reported to be thermally unstable.²² Monolayers of alkyl silanes have been grafted on SiO₂ surface, but the multi-steps protocol required stringent reactions conditions such as control of the optimized temperature and anhydrous conditions. In addition, many of





Scheme 1 Syntheses of the porphyrins.

the alkyl silanes have to be synthesized separately.²³ Hence, we followed electro-grafting for an easy attachment of the porphyrins on Si (111) surface through the strong Si-C bond (Si-C ~ 76 kcal mol⁻¹).^{23b} Organic molecules having a cleavable group such as vinyl (C=C), ethynyl (C \equiv C), halide (Cl, Br, I), tetraalkylammonium, and diazonium silane reacts with H-terminated Si, and can be deposited using electrografting process. The advantage of the process is that the deposition process can be monitored *in situ* by measuring the redox peak of the electrografting reaction.

Presently electrografting of the molecules **5a** and **5b** on highly-doped, commercially available Si (111) surfaces was achieved by conventional cyclic voltammetry (CV). The CVs (Fig. 1), recorded during electrochemical deposition of the molecules **5a** and **5b** on Si showed an irreversible peak at ~ 0.3 V, which was earlier assigned for the bonding of an alkene with the H-terminated Si surfaces.^{14d} Moreover, no peak at 0.3 V appeared when the CV was run using the TBAP solution alone, but similar peak was observed with 1-undecene (taken as reference). This indicated covalent attachment of the porphyrin molecules at the H-terminated Si surfaces is through terminal double bond. The possible electrochemical reactions in the process is schematically shown in ESI (Fig. S1†). In the first step, application of a negative potential to the working electrode produces a radical on silicon and a proton. The Si radical subsequently reacts with the alkene function of **5a** and **5b** to form the Si-C bond, and generates a C-centred radical β to the Si atom. A subsequent transfer H atom from another Si-H bond generates a new Si radical to propagate the process. Formation of the Si-C bond resulted in the irreversible oxidation peak at ~ 0.3 V. As the number of scans increased, the peak diminished owing to the non-availability of nucleophilic Si atoms at the

surface. Using different number of scans (5, 10, 20, 25 and 30), a compact monolayer, as revealed by AFM (Fig. 2) was prepared at 25 and 30 scans respectively with **5a** and **5b**. At higher scans, formation of multilayers was evident by AFM analysis (data not shown).

Monolayer characterization

In order to ascertain the monolayer deposition on Si, the electro-grafted materials were characterized by contact angle measurement, polarized FT-IR spectroscopy, X-ray reflectivity (XRR), ellipsometry, AFM, secondary ion mass spectrometry (SIMS) and electrochemistry. The contact angles of deionized water in case of Si wafers, grafted with **5a** and **5b** were $\sim 58^\circ$ and 64° respectively, whereas for the cleaned Si wafer it was 84° . The observed contact angles were much less than the reported values ($97\text{--}108^\circ$) of the methyl terminated alkyl chains.²⁴ This suggested interaction of the water molecule with the porphyrins, possibly through their pyrrole rings, which is possible only when the molecules are tilted. This was also confirmed by ellipsometry, where the average thicknesses of respective monolayers were found to be $\sim 2.3 \pm 0.2$ nm in case of **5a** and 2.9 ± 0.2 nm with **5b**. The XRR experiments, carried out at room temperature with the monolayers further confirmed their thicknesses. The reflectivity data (Fig. 3) was fitted in MOTOFIT software, using Parratt's formalism. The scattering length density (SLD) values of the monolayers were calculated from the density of monolayer and molecular formula of molecule according to eqn (1).

$$\rho = \frac{NN_a\rho_{\text{mass}}}{M_R} \times \sum_{i=1}^n b_{ci} \quad (1)$$



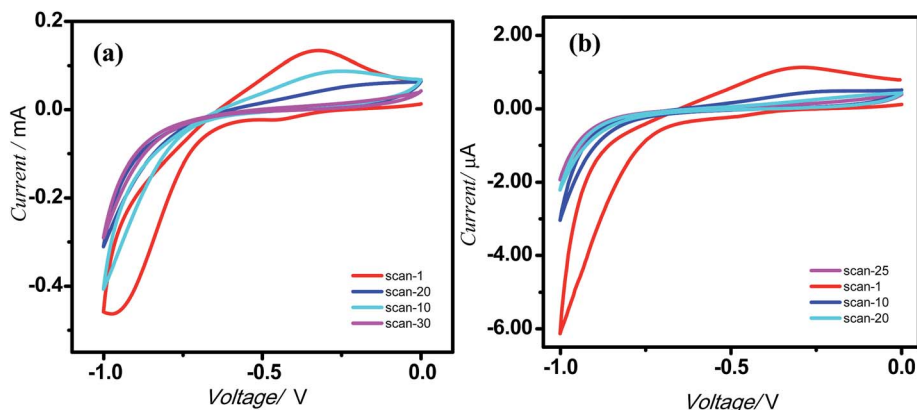


Fig. 1 CVs indicating electrografting of the molecules on silicon (n^{++}) wafers. (a) **5a**; (b) **5b**. The deposition was carried out under N_2 atmosphere at a scan rate of 0.05 V s^{-1} using Si wafers as the WE, Pt as the CE, Ag/AgCl as the RE, $0.1 \text{ M Bu}_4\text{NP}$ as the electrolyte and the porphyrins ($1 \mu\text{M}$) in dry CH_2Cl_2 .

$$b_i = \frac{e^2}{4\pi\epsilon_0 mc^2} f_{1i} \quad (2)$$

where N_a is Avogadro number, ρ_{mass} is the mass density of the material, M_R is its relative molecular mass and b_{ci} is the bound coherent scattering length of the i^{th} atom of a molecule with n atoms. For X-rays, the scattering length for each atom was calculated using eqn (2), where e is the charge on a single electron, ϵ_0 is the permittivity of free space, m is the mass of an electron and c is the speed of light. The scattering factor (f_{1i}) for an atom of element i is available in literature.²⁵ The SLD profile was calculated using eqn (3), where N is the total number of layers, z is the distance from the top interface and erf is the error function.

$$\rho = \sum_{i=0}^N \frac{\rho_i - \rho_{i+1}}{2} \left(1 + \text{erf} \left(\frac{z - z_i}{\sqrt{2}\sigma_i} \right) \right) \quad (3)$$

From the plot of SLD vs. interface distance, the thicknesses for **5a** and **5b** were found to be $2.54 \pm 0.02 \text{ nm}$ and 3.05 ± 0.03

nm respectively (Fig. 3 inset). These values are lower than the theoretically calculated (using Molkel software) length $\sim 3.9 \text{ nm}$ of the porphyrins. The roughness values for the monolayers of **5a** 24.0 \AA ($\text{SLD} = 0.22 \times 10^{-6} \text{ \AA}^{-2}$, $\chi_{5a}^2 = 0.04913$) and **5b** 29.7 \AA ($\text{SLD} = 2.23 \times 10^{-6} \text{ \AA}^{-2}$, $\chi_{5a}^2 = 0.03049$) were close to their thicknesses estimated by ellipsometry. The XRR data also indicated that the tilt angles of the monolayers were $\sim 39^\circ$ and 51.4° for **5a** and **5b** respectively.

The AFM analyses revealed that the monolayers were more organized with lesser number of voids and hillocks, and the void depths were $\sim 2.3 \text{ nm}$ for **5a** and 2.9 nm for **5b** (Fig. 2). The RMS and average roughnesses values of the monolayers were 1.45 and 1.16 nm for **5a**, and 0.89 and 0.73 nm for **5b**. Compared to **5a**, the monolayers of **5b** were more compact and uniform with larger grain size. The fast scan (10 V s^{-1}) CVs (Fig. 4) of the monolayers exhibited a reversible peak at $+0.8 \text{ V}$ for the respective porphyrin moieties and no such peak was observed in bare silicon and undecene deposited silicon. The net charge transferred during the oxidation process, calculated from the area under the oxidation peak were $4.5 \times 10^{-8} \text{ C}$ and 8.8×10^{-7}

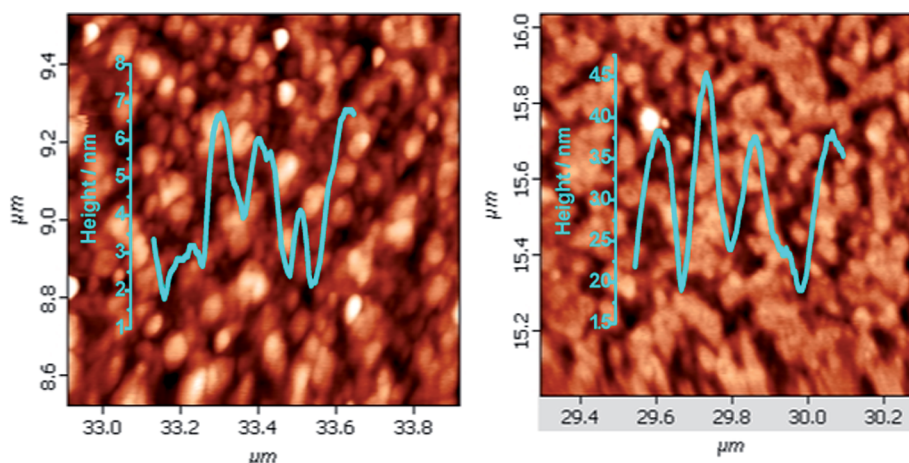


Fig. 2 AFM images ($1 \mu\text{m} \times 1 \mu\text{m}$) for the monolayers of (a) **5a**; (b) **5b**, electro-grafted on silicon (n^{++}) wafers.



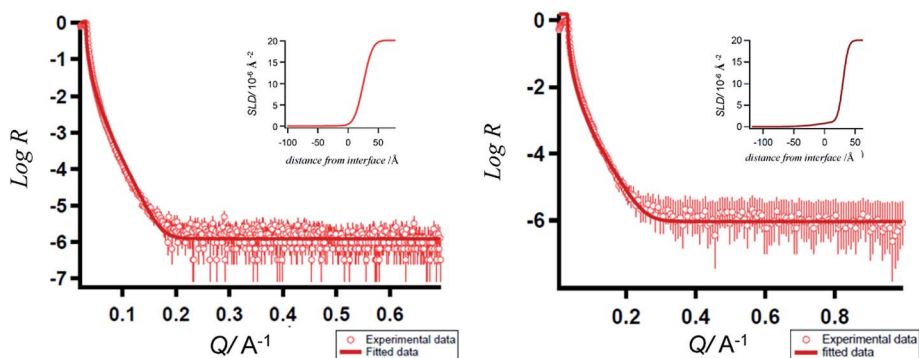


Fig. 3 XRR curves of the porphyrins-grafted monolayers on silicon (n^{++}) wafers. (a) **5a**; (b) **5b**; insets: SLD plots.

C respectively for **5a** and **5b**. These amounted to surface coverages of 4.3×10^{11} and 3.4×10^{12} molecules cm^{-2} respectively for **5a** and **5b**. Thus, the surface covered by **5b** was ~ 8 times that by **5a**. These data are consistent with the AFM analyses, both revealing more compact monolayers with **5b** than **5a**. This may be because of hydrogen bonding amongst the F and H atoms of the porphyrin phenyl moieties.

Identifying the C–H/F–C interaction as a hydrogen bond is questioned due to the poor acceptor ability of C-bonded F atoms compared to the O- and N-atoms, if present.²⁶ However, distinct hydrogen bond character has been reported in the layered crystal structure of fluoroaromatics, where C–H/F–C interactions contribute significantly in stabilizing the layers. This has been attributed to activation of the *ortho*-aromatic protons by the F atom that may override the poor acceptor nature of the C-bonded halogen.²⁷ In addition, the face-to-face noncovalent interaction in arene–perfluoroarene system is ubiquitous, and widely recognised as one of the major driving forces in forming robust supramolecular assemblies.²⁸ This primarily involves stabilizing Coulombic interactions, and has been reported with several fluoroaromatic compounds.²⁹ In the present case, the parallel offset disposition of the fluorophenyl moieties of adjacent porphyrin molecules may also be responsible for the compact monolayers of **5b**.

The SIMS of the monolayer of **5a** showed peaks due to the porphyrin fragments at m/z 665, 646, 461, 400, 356 and 324 amu. In case of **5b**, the peaks appeared at a lower mass range *viz.* m/z 457, 407, 387 and 334 amu. Nevertheless, the SIMS data (Fig. 5(a) and (b)) of the monolayers of **5a** and **5b** confirmed deposition of their respective monolayers on the Si wafers. In case of **5a** monolayers, the secondary ions knocked down the porphyrin moiety from the alkyl spacer, attached to the Si surface. Subsequent ionization of the released porphyrin moiety provided the mass fragments at higher masses. Possibly, the secondary ions cannot penetrate the more compact **5b** monolayers, resulting in the fragmentation of the porphyrin moiety in the middle to generate the low molecular weight mass peaks of the truncated porphyrin moiety.

The polarized FTIR spectra (Fig. 6) for the monolayers of **5a** exhibited N–H stretching frequency at 3249 cm^{-1} , symmetric (ν_s) and asymmetric stretching modes (ν_a) of CH_2 group at 2842 and 2910 cm^{-1} and of CH_3 group at 2877 and 2949 cm^{-1} . In contrast, the respective IR absorption peaks of the monolayers of **5b** were at 3255 cm^{-1} , 2855 and 2925 cm^{-1} , and at 2871 and 2961 cm^{-1} . In pure solid alkane monolayers, the hydrocarbon chains exist in an all-*trans* configuration such that the carbon backbone of each molecule lies in single planes. However, in liquid form, there is a substantial twisting about

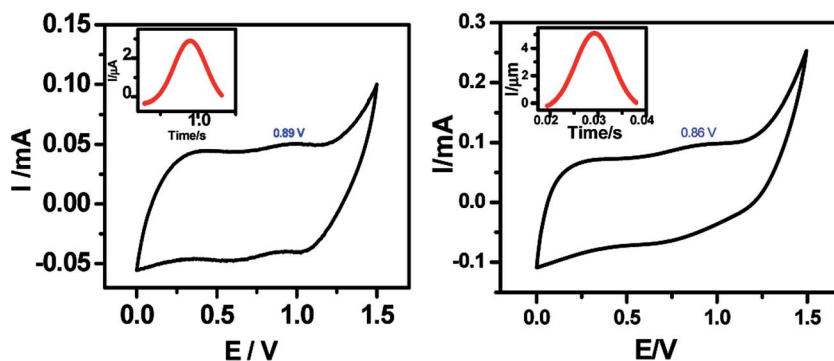


Fig. 4 Fast scan CVs for the monolayers of (a) **5a**; (b) **5b**; electro-grafted on silicon (n^{++}) wafers. The CVs were recorded under N_2 atmosphere at a scan rate of 10 V s^{-1} using the respective monolayer-grafted Si as the WE, Pt as the CE and Ag/AgCl as the RE, and $0.1 \text{ M Bu}_4\text{NP}$ as the electrolyte. The reversible peaks are indicated by circles. Insets show the magnified redox peaks, after background correction and converting the potential scale into time scale.



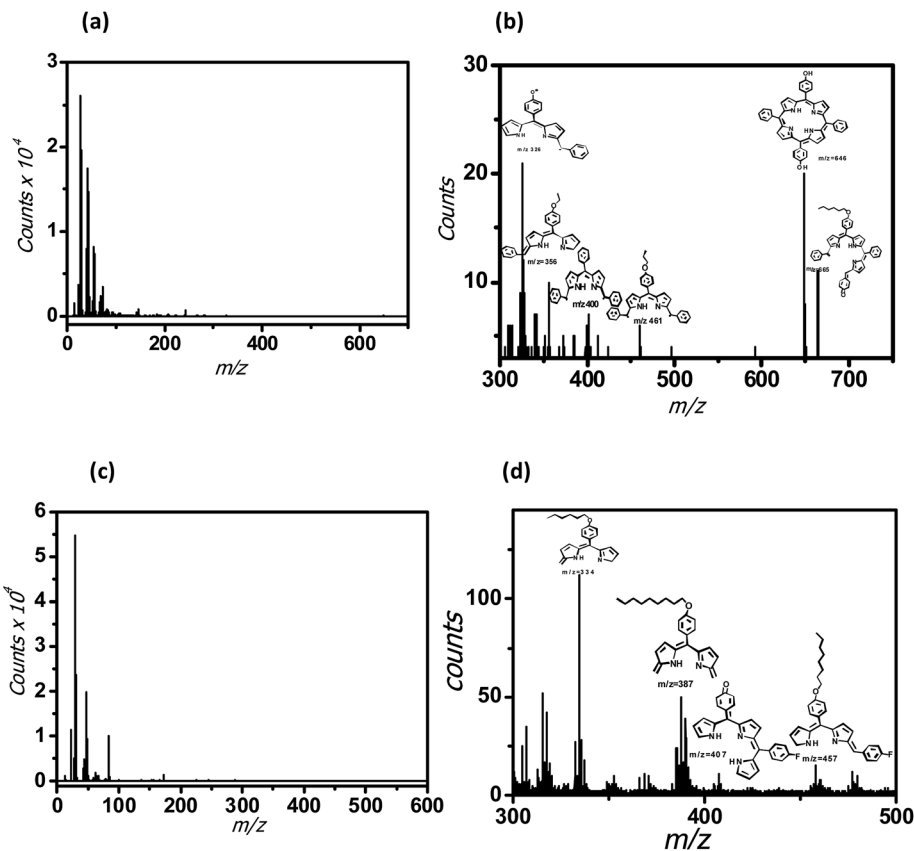


Fig. 5 SIMS of the porphyrins-grafted monolayers on silicon (n^{++}) wafers. (a) 5a; (b) enlarged plot for 5a; (c) 5b; (d) enlarged plot for 5b.

the individual bonds; these out-of-plane twists alter the frequency of the CH_2 vibrational modes.³⁰ Thus, the IR peaks due to the CH_2 vibrational modes can provide better insights about the proposed van der Waals interactions between the porphyrin rings, parallelly anchored on Si. Our IR data showed that the alkyl chains in the monolayers of **5a** are more rigid like in pure solid alkanes, while that in the monolayers of **5b** are more liquid like and twisted. Presumably, in case of **5b**, the phenyl rings of the porphyrin moiety are more tightly packed setting the alkyl chains free to twist. But in case of **5a**, proper packing requires stacking of the porphyrins as well as the alkyl moieties at a tilt angle of 39° . This rigidifies the alkyl chains in **5a**.

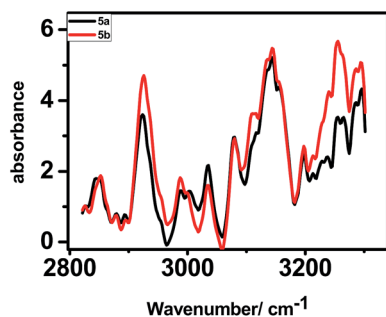


Fig. 6 Polarized FTIR spectra of the monolayers of **5a** and **5b** on silicon (n^{++}) wafers.

I-*V* characteristics

Typical current voltage (*I*-*V*) curves of Hg/molecule/Si (111) wafers are shown in Fig. 7. The hybrid assemblies, prepared from **5a** and **5b** showed reversible NDR behaviour at room temperature with current PVRs of 10 and 100, and peak positions (voltage) at 1.18 V and 1.09 V respectively. The details of the *I*-*V* curves are shown in Table S1.† Interestingly majority of the devices, constructed with both the systems were stable during repetitive voltage scanning for 8 h in positive and negative bias voltages, without any reduction in current or the NDR effect. However, the reversible NDR effect showed only a marginal hysteresis. The Si-alkyl/Hg junctions, used in the studies are very stable, and exclude any possibility of penetration of Hg drops through pinholes or diffusion of mercury vapor through the SAM. Thus, the measured *I*-*V* is expected to be direct. The statistical analyses of data, and junction yields are extremely valuable to discriminate artifacts from real data.³¹ In the present work, we constructed 96 and 48 devices, respectively with the compounds **5a** and **5b**. Of these, 80 and 43 devices, made of **5a** and **5b** showed stable (up to 8 h), and reversible NDR property, although 94 and 46 of these devices showed reversible NDR behavior.

The complete PVR statistics of the devices are shown as the ESI (Table S2† and the accompanying pi-chart), and summarized here. With compound **5a**, the PVR values of 36% of the devices were 8–10, while an additional 37% of the devices



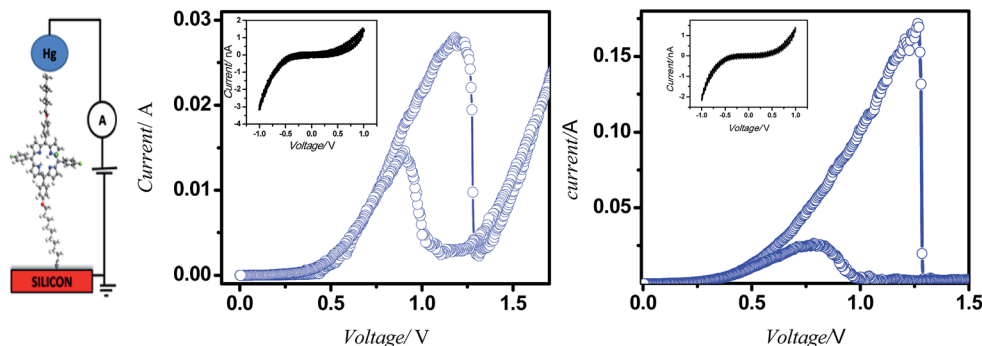


Fig. 7 Device design and characteristics. (a) I - V measurement set up; (b) and (c) I - V plots of the monolayers of **5a** and **5b** on silicon (n^{++}) wafers respectively.

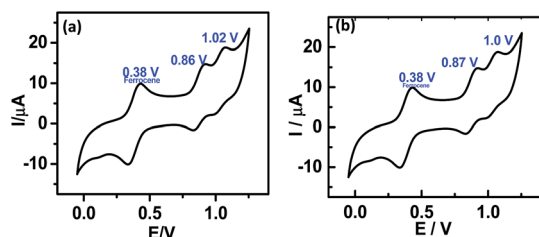


Fig. 8 CV of the porphyrins in solution phase using ferrocene as the standard. (a) **5a**; (b) **5b**.

showed PVR values 5–8. The device statistics of the monolayers of **5b** were more impressive with 39% of the devices showing PVR values of 80–100, an additional 33% with PVR of 50–80, and an additional 24% with PVR of 10–50. The I - V characteristics of the solid state devices can be understood in terms of the molecular properties observed in the solution. Presently, the current flow in both the solid-state devices (Fig. 4) as well as in the respective porphyrin solutions (Fig. 8) showed same oxidation peaks.

The correspondence between the solution and solid-state results suggested that the fundamental molecular electronic properties of the porphyrins are retained in the solid-state devices. Hence, the forward bias current-flow should be determined by the HOMO states of the molecules, while their respective LUMO states would dictate the reverse bias current.

Thus, the NDR effect in forward bias is a result of alignment of the HOMO levels of the molecules with the Fermi-levels of the electrodes. Various mechanisms such as charge transfer-induced change of the charge state, and chemical/conformational changes under finite bias have been proposed to explain NDR phenomenon.³² It is possible that presently, the NDR behaviour depends on a match (resonant tunnelling) between the Fermi levels of electrodes and the HOMO levels of molecules sandwiched between the electrodes, followed by a mismatch of HOMO levels of the oxidized molecules with the Fermi-levels of electrodes. The hypothesis is consistent with the Aviram–Ratner model of molecular rectification.^{4a} However, involvement of additional mechanisms can't be excluded.

Theoretical interpretation

For further clarification, the theoretical calculations of the electronic transport behaviour were carried out. The ground state geometries of the molecules **5a** and **5b** were optimized by *ab initio* molecular orbital calculations. The ionic optimization of molecules **5a** and **5b** was carried out without any symmetry constraint at the B3LYP/6-31G (d,p) level of theory. The geometrical parameters of both molecules were found to be same, except for the C–H and C–F bond lengths, which were 1.09 Å and 1.39 Å, respectively.

Our experimental results revealed that on applying voltage, initially there was a slow rise in the current due to tunnelling.

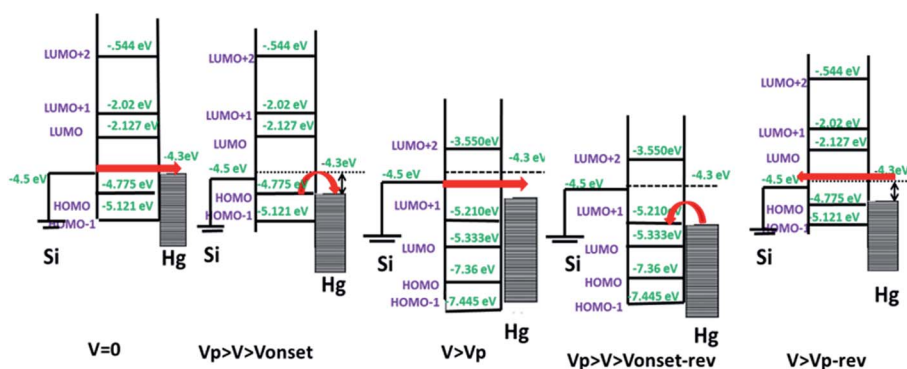


Fig. 9 Diagrammatic presentation of the NDR mechanism for a σ - π - σ system.



But at V_{onset} the HOMO level of the molecule would align in resonance with the Fermi level of Hg. This can explain the sharp increase in current at V_{onset} . At V_p , the molecules get oxidized to the +1 state, causing the misalignment with the Fermi-levels of Hg, and resulting in the current drops. When the voltage is reduced in the reverse scan, the new device will be Si/porphyrin⁺¹/Hg. At $V_{\text{onset-rev}}$, the Fermi level of Hg would align with the LUMO of porphyrin⁺¹. This induces a sharp increase in the current due to resonance tunnelling through the molecule. It again drops at $V_{p\text{-rev}}$ as the molecule gets misaligned with the Fermi levels of Hg during its reduction. The observed small hysteresis may be due to conformational changes in the molecule after oxidation. The experimentally observed voltages are in qualitative agreement with the theoretically calculated HOMO–LUMO values of **5a** and **5b** and their respective +1 oxidation states, using *ab initio* (GAMESS software) (data shown in ESI, Table S3†). The mechanism of NDR effect in **5a** and **5b** is explained schematically in Fig. 9.

Conclusions

In summary, we have synthesized two di-*O*-alkylated porphyrin molecules as prototype σ - π - σ systems, and electro-grafted them on H-terminated Si to form monolayers. The *I*-*V* characteristics of the monolayers revealed pronounced reversible NDR effects with peak-to-valley current ratio of ~ 10 and 100. The NDR effects were relatively stable during repetitive voltage scanning for 8 h in the positive and negative bias, without any reduction in current or in the NDR effect. The higher PVR, observed with the device containing the fluorophenylporphyrin moiety **5b** suggested its better pre-organization possibly by hydrogen bonding through the F atoms, compared to the device, fabricated using the non-fluorinated porphyrin, **5a**. Theoretical simulations of Si/porphyrin/Hg structure showed that the NDR effect is intrinsic to the porphyrin molecules. The NDR effect was explained using the *ab initio* molecular-orbital theoretical calculations.

Experimental section

General methods in synthesis

Reagents and solvents (Sigma-Aldrich and Fluka) were of synthetic grade. Pyrrole and benzoyl chloride used after distillation. 4-Hydroxybenzaldehyde was used after crystallization. All solvents were dried and distilled before use. Tetrahydrofuran (THF) was distilled from Na under argon. Acetone was dried over Na_2CO_3 and HPLC grade acetonitrile was used. The ^1H NMR and ^{13}C NMR spectra were recorded with 200/300/500 (50/75/100) MHz spectrometers using deuterated solvents as the internal standards. The mass spectrometry was carried out with a MSMS (410 Prostar Binary LC with 500 MS IT PDA Detectors, Varian Inc, USA) and MALDI-TOF/TOF (BrukerUltraflex II) data systems.

4-Hexyloxybenzaldehyde (1a) and 4-(10-undecyloxy)benzaldehyde (1b). A mixture of 4-hydroxybenzaldehyde (4.0 g, 32.7 mmol), 1-bromohexane (6.50 g, 39.3 mmol) or 1-bromo-10-undecene (9.16 g, 39.3 mmol), K_2CO_3 (5.52 g, 40 mmol) and

Bu_4NI (10 mol%) in acetone (100 mL) was refluxed till the reaction was complete (*cf.* TLC, ~ 16 h). The mixture was filtered, and concentrated in vacuum. The residue was taken in Et_2O (40 mL) and washed with H_2O (2×10 mL) and brine (1×20 mL), dried, and concentrated *in vacuo*. The residue was purified by column chromatography (silica gel, 5% EtOAc/hexane) to give pure **1a** (6.1 g, 91.2%) and **1b** (8.1 g, 91%).

Compound 1a. colorless liquid; IR (film, ν/cm^{-1}): 3019 (s), 2928 (s), 2856 (s), 1687 (s); ^1H NMR (200 MHz, CDCl_3): δ 0.90 (t, $J = 6.4$ Hz, 3H), 1.15–1.49 (m, 6H), 1.71–1.88 (m, 2H), 4.01 (t, $J = 6.0$ Hz, 2H), 6.97 (d, $J = 9.5$ Hz, 2H), 7.80 (d, $J = 9.5$ Hz, 2H), 9.85 (s, 1H) ppm; ^{13}C NMR (50 MHz, CDCl_3): δ 13.6, 22.2, 25.3, 28.7, 31.2, 68.1, 114.4, 129.6, 131.5, 163.9, 190.04 ppm; MSMS (m/z): 207 (100) [$\text{M} + \text{H}$]⁺; anal. calcd for $\text{C}_{13}\text{H}_{18}\text{O}_2$: C, 75.69; H, 8.80. Found: C, 75.34; H, 9.06%.

Compound 1b. Colorless liquid; IR (film, ν/cm^{-1}): 3019 (s), 2928, 2856 (s), 1687 (s); ^1H NMR (200 MHz, CDCl_3): δ 1.21–1.57 (m, 12H), 1.72–1.95 (m, 2H), 1.96–2.15 (m, 2H), 4.05 (t, $J = 6.0$ Hz, 2H), 4.85–5.08 (m, 2H), 5.67–5.99 (m, 1H), 6.99 (d, $J = 8.0$ Hz, 2H), 7.83 (d, $J = 8.0$ Hz, 2H), 9.88 (s, 1H) ppm; ^{13}C NMR (50 MHz, CDCl_3): δ 25.9, 28.9, 29.0, 29.3, 29.4, 33.7, 68.4, 114.1, 114.8, 129.9, 131.9, 139.1, 164.3, 190.6 ppm; MSMS (m/z): 275.1 (100) [$\text{M} + \text{H}$]⁺; anal. calcd for $\text{C}_{18}\text{H}_{26}\text{O}_2$: C, 78.79; H, 9.55. Found: C, 79.02; H, 9.55%.

Dipyrromethanes 2a and 2b. A mixture of pyrrole (250 mmol), compound **1a** or **1b** (10 mmol) and TFA (1 mmol) was stirred under Ar for 5–10 min. After completion of the reaction, it was quenched with 0.1 M aqueous NaOH (40 mL) and extracted with EtOAc (100 mL). The organic layer was washed with H_2O (3×10 mL) and brine (1×5 mL), dried, and concentrated in vacuum. Excess pyrrole was removed by vacuum distillation at room temperature, and the residue column chromatographed (neutral alumina, 20% EtOAc/hexane) to give the respective products **2a** (1.4 g, 42%) and **2b** (2.0 g, 52%), which were crystallized from hexane.

Compound 2a. White crystals; mp: 58 °C; IR (ν/cm^{-1}): 3463 (m), 3019 (s), 2956 (s), 2859 (s), 2399 (w); ^1H NMR (200 MHz, CDCl_3): δ 0.92 (t, $J = 6.2$ Hz, 3H), 1.25–1.50 (m, 6H), 1.68–1.85 (m, 2H), 3.93 (t, $J = 6.4$ Hz, 2H), 5.42 (s, 1H), 5.85–5.93 (m, 2H), 6.12–6.22 (m, 2H), 6.61–6.68 (m, 2H), 6.84 (d, $J = 7.8$ Hz, 2H), 7.12 (d, $J = 7.8$ Hz, 2H), 7.89 (broad s, 2H) ppm; ^{13}C NMR (50 MHz, CDCl_3): δ 14.1, 22.7, 25.9, 29.4, 31.7, 43.4, 68.3, 107.2, 108.6, 114.8, 117.2, 129.5, 133.1, 134.2, 158.4 ppm; MSMS (CI, m/z): 321.2 (100) [$\text{M} - \text{H}$]⁺; anal. calcd for $\text{C}_{21}\text{H}_{26}\text{N}_2\text{O}$: C, 78.22; H, 8.13; N, 8.69. Found: C, 78.60; H, 8.17; N 8.54%.

Compound 2b. White crystals; mp: 64 °C; IR (ν/cm^{-1}): 3463 (m), 3019 (s), 2928 (s), 2856 (s), 2399 (w), 1639 (w); ^1H NMR (200 MHz, CDCl_3): δ 1.21–1.59 (m, 12H), 1.69–1.84 (m, 2H), 1.95–2.17 (m, 2H), 3.94 (t, $J = 6.0$ Hz, 2H), 4.85–5.09 (m, 2H), 5.43 (s, 1H), 5.65–5.98 (m, 3H), 6.10–6.21 (m, 2H), 6.65–6.74 (m, 2H), 6.85 (d, $J = 8.5$ Hz, 2H), 7.12 (d, $J = 8.5$ Hz, 2H), 7.95 (broad s, 2H) ppm; ^{13}C NMR (50 MHz, CDCl_3): δ 26.2, 29.1, 29.3, 29.5, 29.7, 33.9, 43.4, 68.3, 107.2, 108.6, 114.3, 114.9, 117.2, 129.5, 133.1, 134.2, 139.4, 158.4 ppm; MSMS (CI, m/z): 391.1(100) [$\text{M} + \text{H}$]⁺; anal. calcd for $\text{C}_{26}\text{H}_{34}\text{N}_2\text{O}$: C, 79.96; H, 8.77; N, 7.17. Found: C, 79.62, H, 8.77, N, 7.26%.



Diacetyldipyrromethanes 4a and 4b. A solution of EtMgBr in THF (8.1 mmol) was slowly injected to a stirred solution of **2a** (0.524 g, 1.62 mmol) in toluene (25 mL) under argon. After stirring for 0.5 h at room temperature, the acid chloride **3a** or **3b** (4.05 mmol) in toluene (2 mL) was injected into the resulting brown solution over 10 min, and stirring continued for an additional 10 min. The reaction was quenched with aqueous saturated NH₄Cl (10 mL) and the mixture extracted with EtOAc (20 mL). The organic extract was washed with H₂O (2 × 10 mL) and brine (1 × 5 mL), dried, and concentrated in vacuum. The residue was column chromatographed (neutral alumina, 25% EtOAc/hexane) to obtain brown oil as a 4 : 1 mixture of diacetyl and monoacetyl derivatives of **2a**. The required compounds **4a** (0.532 g, 62%) and **4b** (0.422 g, 46%) were obtained in pure form by triturating the oils with MeOH.

Compound 4a. Light brown powder; mp: 150 °C; IR (ν/cm^{-1}): 3225 (m), 3017 (s), 2928 (s), 2856 (s), 1610 (s); ¹H NMR (200 MHz, CDCl₃): δ 0.89 (t, $J = 6.5$ Hz, 3H), 1.21–1.45 (m, 6H), 1.71–1.88 (m, 2H), 3.94 (t, $J = 6.5$ Hz, 2H), 5.60 (s, 1H), 5.91–6.05 (m, 2H), 6.52–6.66 (m, 2H), 6.88 (d, $J = 6.8$ Hz, 2H), 7.25–7.65 (m, 8H), 7.77 (d, $J = 6.8$ Hz, 4H), 11.08 (s, 2H) ppm; ¹³C NMR (50 MHz, CDCl₃): δ 14.0, 22.6, 26.1, 29.2, 29.3, 31.8, 44.1, 68.1, 111.0, 114.9, 120.7, 128.0, 129.4, 129.7, 131.0, 131.6, 138.4, 141.1, 158.6, 184.4 ppm; MS (DI, m/z): 530 (100) [M]⁺; anal. calcd for C₃₅H₃₄N₂O₃: C, 79.22; H, 6.46; N, 5.28. Found: C, 79.04, H, 6.52, N, 5.52%.

Compound 4b. Light brown powder; mp: 120 °C; IR (ν/cm^{-1}): 3275 (m), 3018 (s), 2932 (s), 2871 (s), 1610 (s); ¹H NMR (300 MHz, acetone-*D*₆): δ 0.87–0.93 (m, 3H), 1.21–1.38 (m, 6H), 1.68–1.82 (m, 2H), 3.99 (t, $J = 6.2$ Hz, 2H), 5.83 (s, 1H), 5.95–6.18 (m, 2H), 6.75–6.97 (m, 4H), 7.16–7.48 (m, 6H), 7.88–8.05 (m, 4H), 11.12 (broad s, 2H) ppm; ¹³C NMR (75 MHz, CDCl₃): δ 13.9, 22.5, 25.7, 29.2, 31.6, 43.5, 43.9, 68.1, 111.0, 114.8, 115.0, 115.4, 120.5, 129.3, 129.5, 130.7, 131.3, 131.5, 131.7, 141.0, 158.3, 162.5, 182.9 ppm; MSMS (CIMS, m/z): 567.4 (100) [M + 1]⁺; anal. calcd for C₃₅H₃₂F₂N₂O₃: C, 74.19; H, 5.69; N, 4.94. Found: C, 73.79, H, 5.43, N, 4.89%. The ¹³C–¹⁹F couplings were not analysed.

Porphyryns 5a and 5b. To a stirred solution of the respective diacetyldipyrromethanes **4a** or **4b** (0.78 mmol) in dry THF/MeOH (10 : 1, 34.3 mL) was added NaBH₄ (1.0 mmol) in portions. After the reduction was complete, the mixture was poured into aqueous saturated NH₄Cl (60 mL) and extracted with CH₂Cl₂ (100 mL). The organic layer was washed with H₂O (2 × 5 mL) and brine (1 × 5 mL), dried, and concentrated in vacuum to get the respective dicarbinols as foam like solids.

Mixtures of each of these compounds and dipyrromethane **2b** (0.78 mmol) in CH₃N (350 mL) were stirred to get a homogeneous solution. TFA (9.49 mmol) was slowly added into these under rapid stirring, followed by addition of DDQ (2.34 mmol) after 5 min. The reaction was stirred for 1 h at room temperature and then quenched with Et₃N (9.49 mmol). The mixture was passed through a pad of alumina and eluted with CH₂Cl₂ until the eluent was colourless. The resulting solution was concentrated, passed through a pad of silica gel, and eluted with CH₂Cl₂ to remove the non-porphyrinic products. The purple fractions were combined and concentrated *in vacuo* to

give the porphyryns **5a** (0.069 g, 10%) and **5b** (0.143 g, 20%) as purple solids, which were recrystallized from CHCl₃/MeOH.

Compound 5a. Purple crystals; mp: 230 °C; IR (ν/cm^{-1}): 3433 (s), 3019 (s), 2928 (s), 2399 (w), 1643 (w); ¹H NMR (200 MHz, CDCl₃): δ –2.79 (s, 2H), 0.97 (t, $J = 6.6$ Hz, 3H), 1.12–1.75 (m, 18H), 1.88–2.20 (m, 6H), 4.23 (t, $J = 6.4$ Hz, 4H), 4.82–5.08 (m, 2H), 5.75–5.98 (m, 1H), 7.21–7.38 (m, 4H), 7.61–7.79 (m, 6H), 8.02–8.28 (m, 8H), 8.78–8.96 (m, 8H) ppm; ¹³C NMR (50 MHz, CDCl₃): δ 14.1, 22.7, 25.9, 26.2, 29.0, 29.2, 29.5, 29.6, 31.7, 33.9, 68.4, 112.8, 113.6, 113.8, 114.2, 118.7, 120.2, 130.8, 134.2, 135.6, 135.8, 138.2, 139.3, 159.1, 161.2164.5 ppm; MALDI-TOF (m/z): 882 [M]⁺; anal. calcd for C₆₁H₆₂N₄O₂: C, 82.96; H, 7.08; N, 6.34. Found: C, 82.94; H, 7.03; N, 6.04%.

Compound 5b. Purple crystals; mp: 225 °C; IR (ν/cm^{-1}): 3434 (s), 3019 (s), 2927 (s), 2850 (s), 1643 (w); ¹H NMR (200 MHz, CDCl₃): δ –2.81 (s, 2H), 1.07 (t, $J = 6.6$ Hz, 3H), 1.25–1.59 (m, 18H), 1.85–2.17 (m, 6H), 4.23 (t, $J = 6.0$ Hz, 4H), 4.86–5.12 (m, 2H), 5.72–5.97 (m, 1H), 7.15–7.32 (m, 4H), 7.35–7.5 (m, 4H), 8.03–8.25 (m, 8H), 8.75–8.99 (m, 8H) ppm; ¹³C NMR (50 MHz, CDCl₃): δ 14.2, 22.7, 25.9, 26.3, 29.5, 29.7, 31.7, 32.0, 68.3, 112.8, 113.6, 113.8, 118.7, 120.2, 130.9, 134.2, 135.6, 135.8, 138.2, 159.1, 161.2, 164.5 ppm; MALDI-TOF (m/z): 918 [M]⁺. anal. calcd for C₆₁H₆₀N₄O₂F₂: C, 79.71; H, 6.58; N, 6.10. Found: C, 79.84; H, 6.64; N, 6.03%. The ¹³C–¹⁹F couplings were not analysed.

Preparation of H-terminated Si wafers

N-type silicon wafers (orientation: 111; resistivity: 0.001–0.005 Ωcm) and 40% NH₄F were purchased from Siltronix and Fluka, respectively. The Si (111) wafers, cut into small pieces (~0.5 cm × 1.5 cm) were cleaned by heating them in 3 : 1 (v/v) of conc. H₂SO₄ : 30% H₂O₂ (piranha) for 10 min at 80 °C. The wafers were removed, washed with excess H₂O and, immersed successively in a deaerated (purged with Ar for 30 min) 40% aqueous NH₄F for 10 min, and 2% aqueous HF for 2 min. The wafers were washed with deionized H₂O for 1 min, dried under a stream of N₂ and immediately taken into the electrochemical cell to perform the electrografting of the porphyryns **5a** and **5b**.

Monolayer formation

The electrochemical deposition of **5a** and **5b** was carried out by CV with a potentiostat/galvanostat system (model: AutolabPG-STAT 30) using the above Si wafers as the working electrode (WE), Pt as the counter electrode (CE) and Ag/AgCl as the reference electrode (RE). The solution contained 0.1 M Bu₄NP as the electrolyte and **5a** and **5b** (1 μM) in dry CH₂Cl₂. The CV was run from 0 to –1 V for 25–50 cycles at 0.05 V s^{–1} scan rate under an inert atmosphere. It was found that homogeneous monolayer was formed at 25 scans for **5a** and 30 scans for **5b**. Homogeneity of monolayer was determined by AFM. After the CV scans, the WE was sonicated in CH₂Cl₂ for 10 min to remove the electrolyte and the unreacted or physisorbed **5a** or **5b**. The WE was further washed with acetone, isopropanol and methanol to obtain the respective grafted monolayers.



Characterization of monolayer

The monolayers were characterized in terms of thickness, using an ellipsometer (Sentech: model SE400adv), surface morphology by AFM (Multiview 4000, Nanonics) imaging, by de-ionized water contact angle (Data Physics System, model: OCA20), FT-IR (Bruker, 3000 Hyperion Microscope with Vertex 80 FTIR System, LN-MCT 315-025 detector) in polarized ATR (20 × objective) mode for 500 scans at an angle of 45°, XRR experiments (TTRAX3 theta-theta goniometer), performed using Cu- α as the X-ray source in a fixed monochromator mode, and molecular mass by SIMS (BARC make, Kore's Technology software). The XRR data were fitted using MOTOFIT software.³³ The roughness and thickness values of the grafted layers were determined at the minimum value of χ^2 for the respective monolayers. The Levenberg–Marquardt algorithm (eqn (4)) was used for obtaining the minimum value of χ^2 , which defines a surface in a multidimensional error space. The deepest valley in the χ^2 surface signifies minimum coefficient values of the fitting function. The CV of the grafted monolayer (as WE) was recorded from 0 to 1 V for 10 cycles at a scan rate 10 V s⁻¹.

$$\chi^2 = \sum_{n=1}^L \frac{1}{L-P} \left(\frac{y_{n,\text{obs}} - y_{n,\text{calc}}}{y_{n,\text{error}}} \right)^2 \quad (4)$$

Junction and measurement setup

To measure the J - V characteristics, a metal/molecule/Si (n^+) structure was completed by using a tiny drop of liquid mercury of diameter 400 μm as the counter electrode. The contact area in the grafted monolayer was 0.2 mm^2 . The J - V curves were recorded at room temperature in a dark box using a pA meter–dc voltage source (HP 4140).

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